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PATENT  
Docket No. JCLA12578  
page 1

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :  
Application No. : 10/728,135  
Filed : December 03,2003  
For : IMMERSION LITHOGRAPHY PROCESS AND MASK LAYER  
STRUCTURE APPLIED IN THE SAME  
Examiner : CHACKO DAVIS, DABORAH  
Art Unit : 1756

**TRANSMITTAL SHEET**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in THIRTEEN ( 13 ) pages.

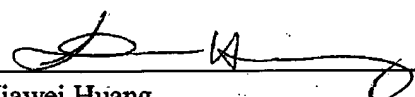
(X) An extension of time to respond for ( 1 ) month(s) is hereby requested.

Time Extension Fee:

- (X) One month (\$120 for Large Entity)  
( ) Two months (\$450 for Large Entity)  
( ) Three months (\$1020 for Large Entity)

(X) Commissioner is authorized to charge the one-month time extension fee in the amount of \$ 120 as calculated above or any other fees required in connection with the filing of this paper to Deposit Account No. 50-0710 (Order No. JCLA12578).

Date: 11/20/2006

  
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